

# United States Patent and Trademark Office

UNITED STATES DEPARTMENT OF COMMERCE United States Patent and Trademark Office Address: COMMISSIONER FOR PATENTS P.O. Box 1450 Alexandria, Virginia 22313-1450 www.usplo.gov

APPLICATION NO.	FILING DATE	FIRST NAMED INVENTOR	ATTORNEY DOCKET NO.	CONFIRMATION NO.
10/712,810	11/13/2003	Richard A. Blanchard	GS 160 D1 8845	
27774	7590 03/14/2006		EXAMINER	
MAYER, FORTKORT & WILLIAMS, PC 251 NORTH AVENUE WEST 2ND FLOOR WESTFIELD, NJ 07090			LE, THAO X	
			ART UNIT	PAPER NUMBER
			2814	
		DATE MAILED: 03/14/2006 .		

Please find below and/or attached an Office communication concerning this application or proceeding.

	Application No.	Applicant(s)			
Office Action Commence	10/712,810	BLANCHARD ET AL.			
Office Action Summary	Examiner	Art Unit			
	Thao X. Le	2814			
The MAILING DATE of this communication app Period for Reply	ears on the cover sheet with the c	orrespondence address			
A SHORTENED STATUTORY PERIOD FOR REPLY WHICHEVER IS LONGER, FROM THE MAILING DA  - Extensions of time may be available under the provisions of 37 CFR 1.13 after SIX (6) MONTHS from the mailing date of this communication.  - If NO period for reply is specified above, the maximum statutory period w  - Failure to reply within the set or extended period for reply will, by statute, Any reply received by the Office later than three months after the mailing earned patent term adjustment. See 37 CFR 1.704(b).	ATE OF THIS COMMUNICATION 36(a). In no event, however, may a reply be timulated and will expire SIX (6) MONTHS from a cause the application to become ABANDONE!	l. ely filed the mailing date of this communication. O (35 U.S.C. § 133).			
Status					
1) Responsive to communication(s) filed on 13 No.	1)⊠ Responsive to communication(s) filed on <u>13 November 2003</u> .				
2a) This action is <b>FINAL</b> . 2b) ⊠ This action is non-final.					
3) Since this application is in condition for allowance except for formal matters, prosecution as to the merits is					
closed in accordance with the practice under E	x parte Quayle, 1935 C.D. 11, 45	3 O.G. 213.			
Disposition of Claims		•			
4) ☐ Claim(s) 24-41 is/are pending in the application 4a) Of the above claim(s) is/are withdray 5) ☐ Claim(s) 24-26 is/are allowed. 6) ☐ Claim(s) 27-41 is/are rejected. 7) ☐ Claim(s) is/are objected to. 8) ☐ Claim(s) are subject to restriction and/or	vn from consideration.				
Application Papers					
9) The specification is objected to by the Examine 10) The drawing(s) filed on is/are: a) acce Applicant may not request that any objection to the Replacement drawing sheet(s) including the correct 11) The oath or declaration is objected to by the Ex	epted or b) objected to by the Eddrawing(s) be held in abeyance. See ion is required if the drawing(s) is obj	e 37 CFR 1.85(a). ected to. See 37 CFR 1.121(d).			
Priority under 35 U.S.C. § 119					
12) Acknowledgment is made of a claim for foreign a) All b) Some * c) None of:  1. Certified copies of the priority documents 2. Certified copies of the priority documents 3. Copies of the certified copies of the priori application from the International Bureau * See the attached detailed Office action for a list	s have been received. s have been received in Applicati rity documents have been receive u (PCT Rule 17.2(a)).	on No ed in this National Stage			
Attachment(s)					
1) Notice of References Cited (PTO-892) 2) Notice of Draftsperson's Patent Drawing Review (PTO-948) 3) Information Disclosure Statement(s) (PTO-1449 or PTO/SB/08) Paper No(s)/Mail Date 11/\$2/03.  S Patent and Trademark Office.	4) Interview Summary Paper No(s)/Mail Da 5) Notice of Informal P 6) Other:				

Application/Control Number: 10/712,810

Art Unit: 2814

#### **DETAILED ACTION**

## Claim Rejections - 35 USC § 103

- 1. The following is a quotation of 35 U.S.C. 103(a) which forms the basis for all obviousness rejections set forth in this Office action:
  - (a) A patent may not be obtained though the invention is not identically disclosed or described as set forth in section 102 of this title, if the differences between the subject matter sought to be patented and the prior art are such that the subject matter as a whole would have been obvious at the time the invention was made to a person having ordinary skill in the art to which said subject matter pertains. Patentability shall not be negatived by the manner in which the invention was made.
- 2. This application currently names joint inventors. In considering patentability of the claims under 35 U.S.C. 103(a), the examiner presumes that the subject matter of the various claims was commonly owned at the time any inventions covered therein were made absent any evidence to the contrary. Applicant is advised of the obligation under 37 CFR 1.56 to point out the inventor and invention dates of each claim that was not commonly owned at the time a later invention was made in order for the examiner to consider the applicability of 35 U.S.C. 103(c) and potential 35 U.S.C. 102(e), (f) or (g) prior art under 35 U.S.C. 103(a).
- 3. Claims 27-29, 32-36, 38-41 are rejected under 35 U.S.C. 103(a) as being unpatentable over US 4893160 to Blanchard in view of US 5216275 to Chen.

Regarding claim 27, Blanchard discloses a power semiconductor device in fig. 4j comprising: a substrate 11of a first conductivity type (N); a voltage sustaining region 12 disposed on said substrate, said voltage sustaining region including an epitaxial layer 12, col. 2 line 10, having a first conductivity type (N); at least one terraced trench 36 located in said epitaxial layer 12, said terraced trench 36 having a plurality of portions

that differ in width to define at least one annular ledge therebetween; at least one annular doped region 39 having a dopant of a conductivity N-type, said annular doped region being located in said epitaxial layer 12 below and adjacent to said annular ledge; a filler material 40/42 substantially filling said terraced trench; and at least one active region 15 of said second conductivity P disposed over said voltage sustaining region 12 to define a junction therebetween.

But, Blanchard does not disclose at least one annular doped region having a dopant of a second conductivity type.

However, Chen discloses a power semiconductor device in fig.

6comprises a n-type substrate 4, a n-type epitaxial layer 5 a trench having either n or p-type conductivity region 6, col. 5 line 55. At the time the invention was made; it would have been obvious to one of ordinary skill in the art to use the doping teaching of Chen with Blanchard's device, because it would have created a device with better on-voltage and breakdown voltage as taught by Chen in col. 1 lines 58-63.

Regarding claims 28-29, Blanchard discloses the device wherein said plurality of portions of the terraced trench includes a smallest width portion and a largest width portion, said smallest width portion being located at a depth in said epitaxial layer such that it is closer to the substrate than a largest width portion, fig. 4j, wherein said plurality of portions of the terraced trench are coaxially located with respect to one another, fig.

Regarding claim 32, Blanchard discloses the device wherein said epitaxial layer has a given thickness and further comprising the step of etching a first portion of the terraced trench by an amount

But, Blanchard does not discloses the etching is substantially equal to 1/(x+1) of said given thickness, where x is equal to or greater than a prescribed number of annular doped regions to be formed in the voltage sustaining region. Accordingly, it would have been obvious to one of ordinary skill in art to the trench etching of Blanchard in the range as claimed, because it has been held that where the general conditions of the claims are discloses in the prior art, it is not inventive to discover the optimum or workable range by routine experimentation. See In re Aller, 220 F.2d 454, 105 USPQ 233, 235 (CCPA 1955).

Regarding claims 33-34, Blanchard discloses the power semiconductor device wherein said material filling the trench is a silicon dioxide dielectric material 40.

Regarding claim 35, Blanchard does not disclose the dielectric material lis silicon nitride.

However, at the time the invention was made; it would have been obvious to one of ordinary skill in the art to replace the layer 40 of silicon nitride material, because both silicon dioxide and silicon nitride can be used interchangeably as a dielectric and would have been considered a mere substitution of art-recognized equivalent values, MPEP 2144.06.

Regarding claim 36, Blanchard does not disclose a dopant is boron. However, as discussed in the claim 27 above, Chen discloses the layer 6 can be N or P-type doping. Thus, using boron for P-type conductivity or phosphorus for N-type doping is standard in the art.

Regarding claims 38-39, Blanchard discloses the device wherein said at least one active region further a gate dielectric 40 and a gate conductor 42 disposed above said gate dielectric 40; first and second body regions 15a/15b located in the epitaxial layer 12 to define a drift region therebetween, said body regions 15a/15b having a second conductivity type; and first and second source regions16a/16b of the first conductivity type located in the first and second body regions, respectively, fig. 4j, wherein said body regions include a deep body regions p+, fig. 4j.

Regarding claims 40-41, Blanchard does not disclose the device wherein said terraced trench has a circular cross-section or cross-sectional shape selected from the group consisting of a square, rectangle, octagon, and a hexagon.

However, Chen discloses the device wherein said trench has a circular cross-section or cross-sectional shape selected from the group consisting of a square, rectangle, octagon, and a hexagon, fig. 3. At the time the invention was made; it would have been obvious to one of ordinary skill in the art to use the cross-sectioned shape teaching of Chen with Blanchard's device, because it would have created a device with better on-voltage and breakdown voltage as taught by Chen in col. 1 lines 58-63.

4. Claims 30-31 and 37 are rejected under 35 U.S.C. 103(a) as being unpatentable over US 4893160 to Blanchard and US 5216275 to Chen as applied to claim 27 above, and further in view of US 6078078 to Gardner.

Regarding claim 30, Blanchard discloses the device wherein said plurality of portions of the terraced trench includes at least two annular ledges and said at least one annular doped region includes at least two annular doped regions, fig. 4j.

But, Blanchard does not disclose the device wherein said plurality of portions of the terraced trench includes at least three portions that differ in width from one another.

However, Gardner discloses a V-gate transistor in fig. 10 comprising a plurality of portions of the terraced trench includes at least three portions that differ in width from one another. At the time the invention was made; it would have been obvious to one of ordinary skill in the art to use the teaching of Gardner with Blanchard's device, because it would have higher packing density for a given substrate as taught by Gardner, see abstract.

Regarding claim 37, Blanchard discloses the device wherein a surface area of the at least two annular ledges are substantially equal to one another.

# Allowable Subject Matter

5. Claims 24-26 are allowed because the prior art of record neither anticipated nor rendered obvious all the limitation of the base claim 24-26 including implating a dopant

Application/Control Number: 10/712,810

Art Unit: 2814

Page 7

of a second conductivity type through the barrier material lining said at leat one annualr ledge and said tranh bottom and into adjacent portion of the epitaxial layer.

### Conclusion

6. Any inquiry concerning this communication or earlier communications from the examiner should be directed to Thao X. Le whose telephone number is (571) 272-1708. The examiner can normally be reached on M-F from 8:00 AM - 4:30 PM.

If attempts to reach the examiner by telephone are unsuccessful, the examiner's supervisor, Wael M. Fahmy can be reached on (571) 272 -1705. The fax phone number for the organization where this application or proceeding is assigned is 571-273-8300.

Information regarding the status of an application may be obtained from the Patent Application Information Retrieval (PAIR) system. Status information for published applications may be obtained from either Private PAIR or Public PAIR. Status information for unpublished applications is available through Private PAIR only. For more information about the PAIR system, see http://pair-direct.uspto.gov. Should you have questions on access to the Private PAIR system, contact the Electronic Business Center (EBC) at 866-217-9197 (toll-free).

Thao X. Le 09 Feb. 2006